



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 16, 2026	
IGI Report Number	LG816626777
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	8.55 X 6.58 X 4.36 MM

GRADING RESULTS

Carat Weight	2.54 CARATS
Color Grade	E
Clarity Grade	VVS 1

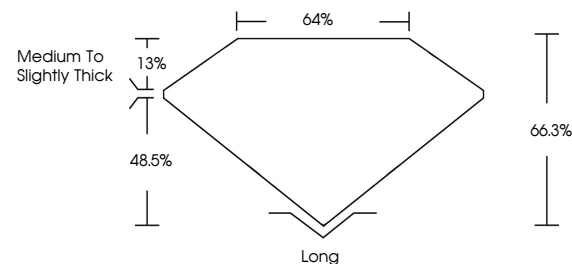
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 15 LG816626777

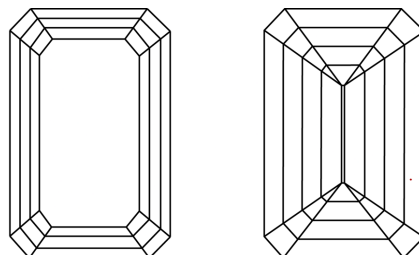
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG816626777
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

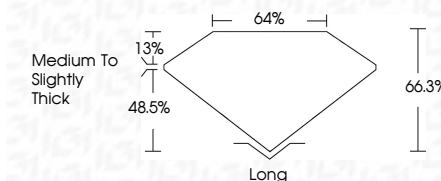
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July 16, 2026
GI Report No LG816626777

GI Report No. 1281636777	2.54 CARATS
HERAUD CUT	E
5.55 X 4.58 X 4.36 MM	VVS 1
	66.3%
	64%
	Medium To Slightly Thick
	Long
	EXCELLENT
	EXCELLENT
	NONE
	gem/2016040277

Comments:
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created by Chemical Vapor Deposition
(CVD) growth process.